

PATENT APPLICATION

Sheet 1 of 2

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO.	SERIAL NO.
	AGL-10030302	
	APPLICANT Qing Gan et al.	
	FILING DATE	GROUP
	Herewith	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	*	DOCUMENT NUMBER	DATE	NAME
VY		6,429,511	August 6, 2002	Ruby et al.
VY		6,376,280	April 23, 2002	Ruby et al.
VY		6,265,246	July 24, 2001	Ruby et al.
VY		6,228,675	May 8, 2001	Ruby et al.

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	TRANSLATION	
					YES	NO

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

VY	US Patent Application Publication No. US 2003/0116825 A1, Publication Date: June 26, 2003.
VY	US Patent Application Publication No. US 2003/0119308 A1, Publication Date: June 26, 2003.
VY	Patent Application Serial No. 10/277,479, filed 10/22/2002, entitled: "Method For Sealing A Semiconductor Device And Apparatus Embodying The Method", Inventor: Frank S. Geefay, 15 pages.

EXAMINER

DATE CONSIDERED

* Copies of these references are not enclosed pursuant to 37 CFR 1.98(d). (See accompanying IDS)

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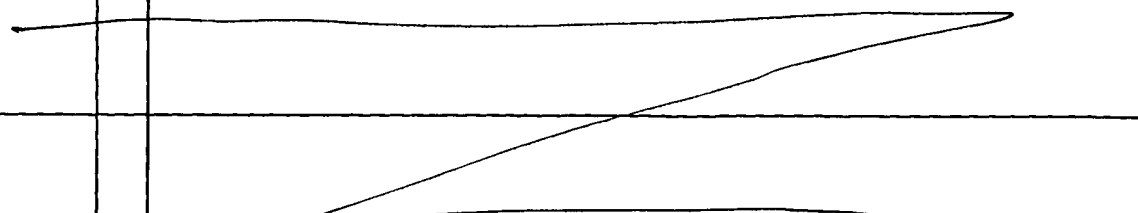
U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

[illegible]

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

54		Patent Application Serial No. 10/286,729, filed 11/1/2002, entitled: "Die Singulation Using Deep Silicon Etching", Inventors: Richard C. Ruby et al. , 20 pages.	
			
EXAMINER	V. Guehner	DATE CONSIDERED	03/30/04

*** Copies of these references are not enclosed pursuant to 37 CFR 1.98(d). (See accompanying IDS)**